



0210 007/97CP 1104
LOC-1103-1-31-98

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Hiroshi Tayanaka

GROUP ART UNIT:

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U.S. SERIAL NO.: 08/818,239

EXAMINER:

MAR 06 1998

DATE FILED: March 14, 1997

GROUP 2500

INVENTION: "METHOD FOR MAKING THIN FILM SEMICONDUCTOR

SOLAR CELL, AND LIGHT EMITTING DIODE"

SUBMISSION OF CERTIFIED COPY OF PRIORITY DOCUMENTS

SIR:

SEP 23 1997

Please enter of record in the file of the above application the

GROUP 1100

attached certified copy of Japanese Application No. P08-234480 filed

September 4, 1996 and P08-061552 filed March 18, 1996 and referred to

in the Declaration filed in this application. Applicant claims priority to the

March 18, 1996 and September 4, 1996 filing dates of the attached

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Japanese Applications under the provisions of 35 U.S.C. Section 119.

MAR 2 1998

Respectfully submitted,

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Commissioner of Patents and Trademarks, Washington, D.C. 20231 on September 11, 1997.